

U.S. Department of Commerce, Patent and Trademark Office						Atty Docket No.		Serial No.	
						M-7511 US		09/825,225	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT						Applicant(s)			
(Use several sheets if necessary)						Larry D. Barto, et al			
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EF	AQ	"Agent Enhanced Manufacturing System Initiative," Technologies for the Integration of Manufacturing Applications (TIMA) (October 1997), NIST Advanced Technology Program http://jazz.nist.gov/atpcf/pjbriefs/pjbrief.cfm?ProjectNumber=97-05-0018 , September 6, 1999							
EF	AR	"Factory Integration," The National Roadmap for Semiconductors: Technology Needs, 1997 Edition http://notes.sematech.org/ntrs/PubINTRS.nsf/pages/97melec.htm							
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EF	AQ	Ehteshami, Babak, Raja G. Petrakian and Phyllis M. Shabe, "Trade-Offs in Cycle Time Management Hot Lots," <i>IEEE Transactions on Semiconductor Manufacturing</i> , Vol. 5, No. 2, pp. 101-106							
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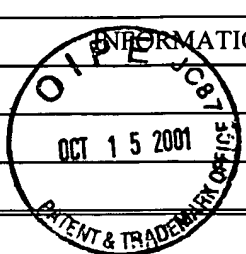
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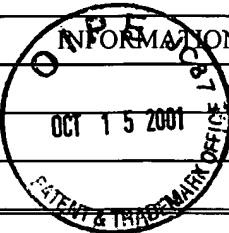
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EF	AS	Ramos, C., Almeida, A. and Vale, Z. "Scheduling Manufacturing Tasks Considering Due Dates: A New Method Based on Behaviors and Agendas", <i>International Conference on Industrial and Engineering Applications of Artificial Intelligence Expert Systems</i> , Melbourne, Australia, 1995, pp. 745-751							
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